ABSTRACT

A method of manufacturing a disk-shaped substrate includes a first step of supplying a fluid to a holding surface of a holding portion that holds one surface of a disk-shaped substrate during a period in which the disk-shaped substrate is not held, and removing foreign matter adhered to the holding surface; a second step of suctioning the foreign matter removed from the holding surface while executing the supply of the fluid in the first step; a third step of causing the one surface of the disk-shaped substrate to be held to the holding surface to which the fluid has been supplied; and a fourth step of executing, with respect to the disk-shaped substrate held to the holding surface, at least one process selected from the group consisting of cutting processing, grinding processing, and polishing processing.

[FIG .5]